



**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q76993

Sadayuki OHNISHI

Appln. No.: 10/646,709

Group Art Unit: 2814

Confirmation No.: 9821

Examiner: Phat X. CAO

Filed: August 25, 2003

For: SEMICONDUCTOR DEVICE WITH INTERLAYER DIELECTRIC FILM AND  
MANUFACTURING METHOD THEREOF

**AMENDMENT UNDER 37 C.F.R. § 1.114(c)**

**MAIL STOP RCE**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Further to the Amendment Under 37 C.F.R. § 1.116 filed on November 9, 2005, in response to the Office Action dated August 9, 2005, please amend the above-identified application as follows on the accompanying pages. A Request for Continued Examination is being filed concurrently herewith.

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